

## Publikationen

(2020): Mid spatial frequency error prevention strategies for the grinding process. In: Proceedings of SPIE 11478 (Seventh European Seminar on Precision Optics Manufacturing [8 July 2020; Teisnach]), Bellingham, WA, USA. DOI: 10.1117/12.2565261.

(2020): On the metrology and analysis of MSF error. In: Proceedings of SPIE 11478 (Seventh European Seminar on Precision Optics Manufacturing [8 July 2020; Teisnach]), Bellingham, WA, USA. DOI: 10.1117/12.2566251.

(2019): MSF-error prevention strategies for the grinding process. In: Proceedings of SPIE 11171 (Sixth European Seminar on Precision Optics Manufacturing, 1117101 [9-10 April 2019, Teisnach]), Bellingham, WA, USA. DOI: 10.1117/12.2526581.

(2018): On the metrology of the MSF errors. In: Proceedings of SPIE 10829 (Fifth European Seminar on Precision Optics Manufacturing [April 10-11, 2018; Teisnach]). DOI: 10.1117/12.2318675.

(2018): Simulation of MSF errors using Fourier transform. In: Proceedings of SPIE 10829 (Fifth European Seminar on Precision Optics Manufacturing [April 10-11, 2018; Teisnach]). DOI: 10.1117/12.2317484.

(2018): EmmaV - Entstehungsmechanismen mittelfrequenter Fehler und deren aktive Vermeidung. Posterpräsentation. In: 5. Tag der Forschung, Deggenndorf.